L Number	Hits	Search Text	DB	Time stamp
1	4	(((anti near reflective near coating near layer) with (silicon near carbide or SiC)) and (dual near damascene)) not (@ad>20010628 or @rlad>20010628)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/11/09 12:13
-	2	(photoresist or (photo near resist)) same (poisoned or poisoning or poison) and (dual near damascene) and (((silicon near carbide) or SiC) with nitrogen)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/11/09 12:01
-	259	damascene and (SiCN or (silicon near carbide near nitride))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/05/27 15:01
-	0	damascene and ((SiCN or (silicon near carbide near nitride)) same barrier) and (poison with (photoresist or (photo near resist)))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/05/27 15:03
-	117	damascene and ((SiCN or (silicon near carbide near nitride)) same barrier)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/05/27 15:03
-	11	(barrier near layer) same (SiCN or "silicon carbide nitride") same (SiC or "silicon carbide")	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/05/28 12:54
-	197	maydan.in.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/05/28 12:55
-	104	maydan.in. and semiconductor	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/05/28 12:55
-	69	(maydan.in. and semiconductor) and apparatus	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/05/28 12:55
-	2	"20020106895"	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/11/07 15:50
-	306	(((438/638) or (438/637) or (438/627) or (438/702)).CCLS.) and (silicon near carbide or SiC)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/11/07 16:23
-	51	(dual near damascene) and (SiCN or "silicon carbide nitride") same (SiC or "silicon carbide")	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/11/07 16:34
-	3191	((438/638) or (438/637) or (438/627) or (438/702)).CCLS.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/11/07 16:49
-	83	(anti near reflective near coating near layer) and (dual near damascene)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/11/09 12:02

| | | 59 | ((anti near reflective near coating near layer) and (dual near damascene)) not (@ad>20010628 or @rlad>20010628) | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB | 2003/11/09 12:12 |